



JFW

In re Application of: TAKESHI MATSUNUMA  
 Application No. 10/630,747  
 Filed: July 31, 2003  
 For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE THROUGH USE OF MASK MATERIAL

U.S. Patent and Trademark Office  
 220 20<sup>th</sup> Street S. Customer Window, Mail Stop Amendment  
 Crystal Plaza Two, Lobby, Room 1B03  
 Arlington, VA 22202

Sir:

Small entity status is claimed for this application under 37 CFR 1.27.

Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.

Other:

Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

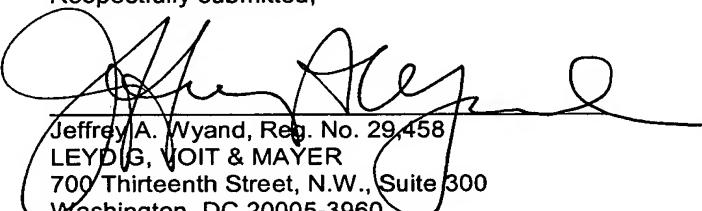
					SMALL ENTITY	OTHER THAN A SMALL ENTITY				
TIME EXTENSION PETITION FEE	none			\$ 0.00	\$ 0.00					
	subtract time extension fee previously paid			(\$ 0.00)	(\$ 0.00)					
<hr/>										
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDT. CLAIM FEE	ADDT. CLAIM FEE			
TOTAL		MINUS		=0	x 9=	\$	x 18= \$			
INDEPENDENT		MINUS		=0	x 44=	\$	x 88= \$			
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM			+ 150=	\$	+ 300=	\$			
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TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL \$			

The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.

Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

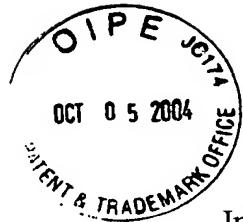
Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

  
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Date: October 5, 2004

**PATENT**  
Attorney Docket No. 402729



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

**TAKESHI MATSUNUMA**

Application No. 10/630,747

Art Unit: 2822

Examiner: M. Guerrero

Filed: July 31, 2003

For: **METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE  
THROUGH USE OF MASK  
MATERIAL**

**RESPONSE TO OFFICE ACTION**

U.S. Patent and Trademark Office  
220 20<sup>th</sup> Street S. Customer Window, Mail Stop Amendment  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Dear Sir:

In response to the Office Action dated July 12, 2004, please enter the following amendments and consider the following remarks.